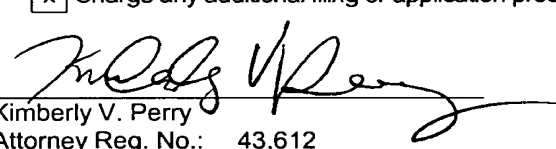




| AMENDMENT TRANSMITTAL LETTER | | | | | Docket No. TESSERA 3.0-081 DIV CONT | |
|--|---|---|-----------------------------------|----------------------------------|---|------|
| Application No. 09/638,079 | | Filing Date August 14, 2000 | | Examiner P. Dang | | |
| | | | | Group Art Unit 2818 | | |
| Applicant(s): Thomas H. DiStefano and Joseph Fjelstad | | | | | | |
| Invention: METHODS FOR PROVIDING VOID-FREE LAYERS FOR SEMICONDUCTOR ASSEMBLIES | | | | | | |
| TO THE COMMISSIONER FOR PATENTS | | | | | | |
| Transmitted herewith is an amendment in the above-identified application. | | | | | | |
| The fee has been calculated and is transmitted as shown below. | | | | | | |
| CLAIMS AS AMENDED | | | | | | |
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | | |
| Total Claims | 40 | - 40 = | 0 | x | 18.00 | 0.00 |
| Independent Claims | 8 | - 8 = | 0 | x | 80.00 | 0.00 |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | | |
| Other fee (please specify): | | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | | 0.00 |
| <input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity | | | | | | |
| <input checked="" type="checkbox"/> No additional fee is required for this amendment. | | | | | | |
| <input type="checkbox"/> Please charge Deposit Account No. <u>12-1095</u> in the amount of \$ _____ A duplicate copy of this sheet is enclosed. | | | | | | |
| <input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed. | | | | | | |
| <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge and credit Deposit Account No. <u>12-1095</u> as described below. A duplicate copy of this sheet is enclosed. | | | | | | |
| <input checked="" type="checkbox"/> Credit any overpayment. | | | | | | |
| <input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17. | | | | | | |
|  Kimberly V. Perry Attorney Reg. No.: 43,612 | | | | Dated: <u>September 14, 2001</u> | | |
| LERNER, DAVID, LITTENBERG, KRUMHOLZ & MENTLIK, LLP 600 South Avenue West Westfield, New Jersey 07090 (908) 518-6361 | | | | | | |

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TESSERA 3.0-081 DIV CONT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
DiStefano et al.

Application No. 09/638,079

Filed: August 14, 2000

For: METHODS FOR PROVIDING
VOID FREE LAYERS FOR
SEMICONDUCTOR ASSEMBLIES

Group Art Unit: 2818

Examiner: P. Dang

Date: September 14, 2001

Commissioner for Patents
Washington, D.C. 20231

X

AMENDMENT

Sir:

In response to the Official Action mailed
June 18, 2001, Applicants submit the following remarks.

I hereby certify that this correspondence is being
deposited with the United States Postal Service with sufficient
postage as First Class mail in an envelope addressed to
Commissioner for Patents, Washington, D.C. 20231 on September
14, 2001.



(Signature)

Kimberly V. Perry

Typed or Printed Name of Person Signing Certificate

#6/Response/Election
Unknown
PATENT
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